Notice of Allowability	Application No.	Applicant(s)		
	10/772,280	KOIKE ET AL.		
	Examiner	Art Unit		
	Tu-Tu Ho	2818		
	14-14 110	2010		
The MAILING DATE of this communication apper All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIC of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED or other appropriate comm GHTS. This application is	in this application. If not included nunication will be mailed in due court	se. THIS	
1. \boxtimes This communication is responsive to <u>Proposed Amendment</u>	t filed 01/24/2006			
2. X The allowed claim(s) is/are 1.3-8.10-12 and 21-23.				
 3. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the: 1. Certified copies of the priority documents have) or (f).		
Certified copies of the priority documents have	been received in Applicat	ion No		
Copies of the certified copies of the priority doc	cuments have been receiv	ed in this national stage application t	rom the	
International Bureau (PCT Rule 17.2(a)).				
* Certified copies not received:				
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		le a reply complying with the require	ments	
4. A SUBSTITUTE OATH OR DECLARATION must be submi INFORMAL PATENT APPLICATION (PTO-152) which give			CE OF	
5. CORRECTED DRAWINGS (as "replacement sheets") mus	t be submitted.			
(a) I including changes required by the Notice of Draftsperson	on's Patent Drawing Revie	ew (PTO-948) attached		
1) 🔲 hereto or 2) 🔲 to Paper No./Mail Date			•	
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	Amendment / Comment	or in the Office action of		
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the			k) of	
 DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F 	sit of BIOLOGICAL MAT FOR THE DEPOSIT OF B	FERIAL must be submitted. Note IOLOGICAL MATERIAL.	the	
Attachment(s)				
1. ☐ Notice of References Cited (PTO-892)	5. Notice of	nformal Patent Application (PTO-15	2)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		Summary (PTO-413),		
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Mail Date 8), 7. Examiner's Amendment/Comment			
Paper No./Mail Date <u>03/16/2005</u> 4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛭 Examiner	8. Examiner's Statement of Reasons for Allowance		
5. Diological material	9. 🗌 Other	-· TH		
		Tu-Tu Ho Jan. 30, 20	06	

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DETAILED ACTION

1. Applicant's Proposed Amendment filed 01/24/2006, resulting from the discussions in the Personal Interview on 12/05/2005, has been reviewed and placed of record in the file.

EXAMINER'S AMENDMENT

- 2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.
- 3. This application is in condition for allowance except for the presence of claims 13-20 to an invention non-elected with traverse in the reply filed 05/25/2005. However, the traversal has not been found persuasive, as detailed in the office action mailed 06/16/2005, and the election has been treated as an election without traverse (MPEP § 818.03(a)). Accordingly, claims 13-20 have been cancelled.

Allowable Subject Matter

4. Claims 1, 3-8, 10-12, and 21-23 are allowable over the prior art of record.

The following is an examiner's statement of reasons for allowance: The prior art of record fails to teach or render obvious a semiconductor device with all exclusive limitations as recited in claims 1, 8, and 21, comprising a substrate; an insulating film formed above the substrate and

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including a metal, Si, N and O; and an electrode formed above the insulating film; the insulating film including metal-N bonds distributed throughout the thickness of the insulating film in an amount of 1 atomic% or more.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tu-Tu Ho whose telephone number is (571) 272-1778. The examiner can normally be reached on 6:30 am - 5:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, DAVID NELMS can be reached on (571) 272-1787. The fax phone number for the organization where this application or proceeding is assigned is (571) 273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Tu-Tu Ho

January 30, 2006